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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shigeo Ashigaki, et al.

U.S. Serial No.: 10/591,345

Group Art Unit: 1756

Filed: : August 31, 2006

Examiner: To Be Assigned

For: PEELING-OFF METHOD AND REWORKING METHOD OF
RESIST FILM

FIFTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

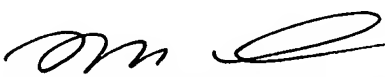
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and copies of the documents cited in the enclosed Korean Office Action dated September 17, 2007. U.S. Patent No. 6,159,646 corresponds to KR 1999-029141.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed in advance of the receipt of a first Office Action in this application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,
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